


Search Notes 	Application/Control No. 10049647	Applicant(s)/Patent Under Reexamination TOILLON ET AL.
	Examiner Rutkowski, Jeffrey	Art Unit 2619

SEARCHED			
Class	Subclass	Date	Examiner
370	351, 389, 392, 401 (updated search)	08/22/2008	JMR
370	242 (physical layer and logical layer analysis concepts)	08/22/2008	JMR

SEARCH NOTES		
Search Notes	Date	Examiner
searched EAST for logical and physical layer analysis concepts	08/22/2008	JMR

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
370	242, 389, 401 (see attached notes)	08/2/2008	JMR

--	--